

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

DECLARATION FOR PATENT APPLICATION

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name.

I believe I am an original, first and joint inventor of the subject matter which is claimed and for which a patent is sought on the invention entitled:

MIS CAPACITOR AND METHOD OF FORMATION

the specification of which is attached hereto.

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by an amendment, if any, specifically referred to in this oath or declaration.

I acknowledge the duty to disclose all information known to me which is material to patentability as defined in Title 37, Code of Federal Regulations, § 1.56.

I hereby claim foreign priority benefits under Title 35, United States Code § 119/365 of any foreign application(s) for patent or inventor's certificate listed below and have also identified below any foreign application for patent or inventor's certificate having a filing date before that of the application on which priority is claimed:

Prior Foreign Application(s)			Priority Not Claimed
_____ (Number)	_____ (Country)	_____ (Filing Date)	<input type="checkbox"/>
_____ (Number)	_____ (Country)	_____ (Filing Date)	<input type="checkbox"/>
_____ (Number)	_____ (Country)	_____ (Filing Date)	<input type="checkbox"/>

I hereby claim the benefit under Title 35, United States Code, § 120/365 of any United States and PCT international application(s) listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States application in the manner provided by the first paragraph of Title 35,

United States Code, § 112, I acknowledge the duty to disclose all information known to me to be material to patentability as defined in Title 37, Code of Federal Regulations, § 1.56(a) which became available between the filing date of the prior application and the national or PCT international filing date of this application:

_____ (Application No.)	_____ (Filing Date)	_____ (Status) (patented, pending, abandoned)
_____ (Application No.)	_____ (Filing Date)	_____ (Status) (patented, pending, abandoned)
_____ (Application No.)	_____ (Filing Date)	_____ (Status) (patented, pending, abandoned)

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

Please address all correspondence to Thomas J. D'Amico of Dickstein Shapiro Morin & Oshinsky LLP located at 2101 L Street NW, Washington, DC 20037-1526. Telephone calls should be made to (202) 785-9700.

Full name of first inventor: Cem Basceri

Inventor's signature: Cem Basceri Date: 5-2-02

Residence: Boise, Idaho

Citizenship: Turkey

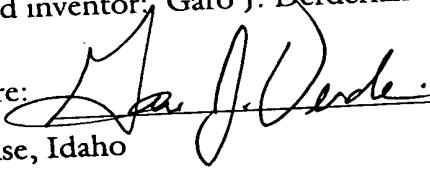
Mailing Address: 314 East Iowa Drive  
Boise, Idaho 83706

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Signature Page for Second Inventor

Full name of second inventor: Garo J. Derderian

Inventor's signature:



Date: 5/2/02

Residence: Boise, Idaho

Citizenship: US

Mailing Address: 6184 S. Schooner Place  
Boise, Idaho 83716

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Cem Basceri, et al.

Application No.: Not Yet Assigned

Group Art Unit: N/A

Filed:

Examiner: Not Yet Assigned

For: MIS CAPACITOR AND METHOD OF  
FORMATION

**POWER OF ATTORNEY BY ASSIGNEE AND  
CERTIFICATE BY ASSIGNEE UNDER 37 CFR § 3.73(B)**

Assistant Commissioner for Patents  
Washington, DC 20231

Dear Sir:

Micron Technology, Inc., Assignee of the entire right, title and interest in the above-identified application by virtue of the Assignment attached hereto (which is also being submitted concurrently for recordation), hereby appoints the attorneys and agents of the firm of Dickstein Shapiro Morin & Oshinsky LLP located at 2101 L Street NW, Washington, DC 20037-1526, listed as follows:

Gary M. Hoffman	26,411	John C. Luce	34,378	Steven I. Weisburd	27,409
Thomas J. D'Amico	28,371	Peter McGee	35,947	Mialecka C. Williams-Bibbs	48,037
Donald A. Gregory	28,954	William E. Powell, III	39,803	Jeremy A. Cubert	40,399
James W. Brady, Jr.	32,115	Patrick T. Skacel	47,948	Gianni Minutoli	41,198
Jon D. Grossman	32,699	Stephen A. Soffen	31,063	Michael Bergman	42,318
Mark J. Thronson	33,082	Christopher M. Tanner	41,518	Salvatore P. Tamburo	45,153
Eric Oliver	35,307	Ellen S. Tao	43,383	Peter Veytsman	45,920
Laurence E. Fisher	37,131	Gary L. Veron	39,057	Christopher S. Chow	46,493
Ryan H. Flax	48,141				

and also, listed as follows:

Charles B. Brantley, III	38,086	Kevin D. Martin	37,882	David J. Paul	34,692
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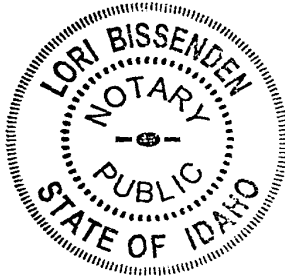
We agree that, when requested, we shall, without charge to Micron Technology, Inc. but at its expense, sign all papers, and do all acts which may be necessary, desirable or convenient in connection with said applications, patents, or other forms of protection.

Cem Basceri  
Cem Basceri

Date: 5-2-02

United States of America )  
State of Idaho ) ss.:  
County of Ada )

On this 2<sup>nd</sup> day of May, 2002, before me personally came Cem Basceri, to me known to be the individual described in and who executed the foregoing instrument, and acknowledged execution of the same.



Lori Bissenden  
Notary Public